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Docket No.: 2336-247

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Application of

Inventor(s): Joo Ho LEE et al.

U.S. Patent Application No. 10/790,723

Filed: March 3, 2004

For: WAFER LEVEL PACKAGE FOR MICRO DEVICE AND MANUFACTURING
METHOD THEREOF

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:
: Confirmation No.2626
:
: Group Art Unit: 2826
:
: Examiner: FETSUM ABRAHAM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of the first Office Action on the merits, but before the mailing date of the Final Rejection or Notice of Allowance.

CERTIFICATION PARAGRAPH

The undersigned hereby certifies that no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart

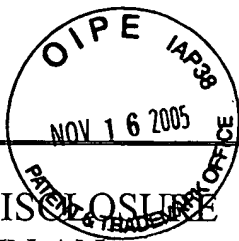
foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in Sec. 1.56(c) more than three months prior to the filing of the information disclosure statement (37 CFR 1.97(e)(2)).

Respectfully submitted,

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INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION

(PTO-1449)

ATTY. DOCKET NO.
2336-247

U.S. PATENT
APPLICATION NO.
10/790,723

APPLICANT
Joo Ho LEE et al.

FILING DATE
March 3, 2004

GROUP
2826

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	6,452,238	9/2002	Orcutt et al			

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	2001-144117 (U.S. 6,452,238)	5/2001	JP				

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.